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Substitute for form 1449A/PTO Complete if Known **Application Number** 10/032,649 INFORMATION DISCLOSURE **Filing Date** October 26, 2001 STATEMENT BY APPLICANT First Named Inventor WEISS, Paul S. Art Unit 1756 (Use as many sheets as necessary) Examiner Name SAGAR, Kripa Sheet of Attorney Docket Number P05396US01

	U.S. PATENT DOCUMENTS						
Examiner Initials *	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
113	,	US- 5,648,201	07/15/1997	Dulcey et al.			
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FOREIGN PATENT DOCUMENTS							
Examiner Initials *	Cite No.	Foreign Patent Document Country Code ³ -Number ⁴ - Kind Code ⁶ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passag or Relevant Figures Appear	Т 6	
14		EP 0506 993 A1	10/07/1992	Geo-Centers, Inc.			
W		WO 03/023517 A1	03/20/2003	Postech Foundation			
Hela		WO 97/38802	10/23/1997	Texas A & M Univ. Sys			
TICS		WO 97/39151	10/23/1997	Affymetrix, Inc.			
ك	,	WO 98/58293	12/23/1998	Biotools - Institut			
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS					
Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), tille of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²		
الع		Calvert, "Lithographic patterning of self-assembled films", J. Vc. Sci. Technol. B. 11(6):2155-2163 (1993)			
W		Goelzhaeser et al., "Chemical Nanolithography with Electron Beams", Advanced Materials, VCH Verlagsgesellschaft, Weinheim, DE, 13(11) 806-809 (2001)			
iU		Müller et al., "A Strategy of the Chemical Synthesis of Nanostructures", Science, Vol. 268, pp. 272-273 (1995)			
1 (S		Sakaki et al., "A Novel Synthesis of β-Ketothioesters", Chem. Parm. Bull, 38(8) 2262-2264 (1990)	†		
10		Yan et al., "Patterning a Preformed, Reactive SAM Using Microcontact Printing", J. Am. Chem. Soc. 120:6179-6180 (1998)			

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